

TSMC-02-1388



January 6, 2004

To: Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
28 Davis Avenue
Poughkeepsie, N.Y. 12603

Subject: | Serial No. 10/694,683 10/28/03 |

Hsu Hsien-Jung et al.

A FLOATING PROCESS FLOW CONTROL
SYSTEM TO HANDLE OPERATION EVENTS
IN A FULL AUTOMATION PLANT

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation
In An Application.

The following Patents and/or Publications are submitted to
comply with the duty of disclosure under CFR 1.97-1.99 and
37 CFR 1.56.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first class
mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450, on January 27, 2004.

Stephen B. Ackerman, Reg.# 37761

Signature/Date

 1/27/04

TSMC-02-1388

U.S. Patent 5,612,886 to Weng, "Method and System for Dynamic Dispatching in Semiconductor Manufacturing Plants," describes a method and a system to perform dynamic dispatching in a semiconductor manufacturing plant.

U.S. Patent 6,546,364 to Smirnov et al., "Method and Apparatus for Creating Adaptive Workflows," describes an adaptive workflow system with a schedule engine and a workflow engine.

Sincerely,

A handwritten signature in black ink, appearing to be 'SBA', written over the printed name.

Stephen B. Ackerman,
Reg. No. 37761

Form PTO-1449

Doctor: Huachol (Cp-dimer)

Applicant Number

TSMC-02-1388

10/694, 683

Lyndon

Hsu Hsien-Jung et al.

Filing Date

10/28/03

Q: ouu A: Uu

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

| | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | Translation | |
|--|-----------------|------|---------|-------|----------|-------------|----|
| | | | | | | YES | NO |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |

OTHER DOCUMENTS (Including Author, Title, Date, Portion or Pages, Etc.)

[illegible]

ἘΛΛΗΝΕΣ

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.



TSMC-02-1388

January 6, 2003

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
28 Davis Avenue
Poughkeepsie, N.Y. 12603

Subject: | Serial No. 10/694,683 10/28/03 |

Hsu Hsien-Jung et al.

A FLOATING PROCESS FLOW CONTROL
SYSTEM TO HANDLE OPERATION EVENTS
IN A FULL AUTOMATION PLANT

ASSOCIATE POWER OF ATTORNEY

I hereby appoint Doug Schnabel, registration number
47,927, as my associate attorney in this case. His telephone
number is (517) 686-3462.

Please continue to direct all correspondence in this case
to the undersigned attorney.

Respectfully submitted,

Stephen B. Ackerman,

Principal attorney of record